



**ELECTRONIC COPY**

LG759525987  
Report verification at igi.org



December 24, 2025

IGI Report Number **LG759525987**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **10.17 X 7.34 X 4.46 MM**

**GRADING RESULTS**

Carat Weight **2.09 CARATS**

Color Grade **E**

Clarity Grade **VS 1**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

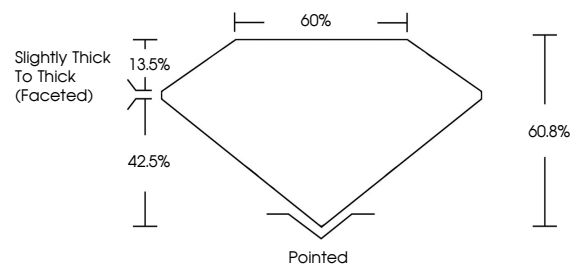
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG759525987**

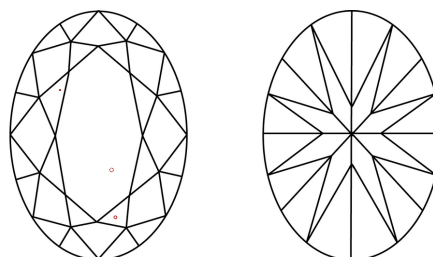
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

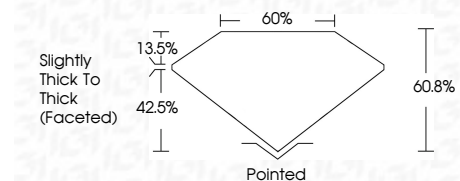
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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IGI Report No LG759525987  
OVAL BRILLIANT  
2.09 CARATS  
E  
10.17 X 7.34 X 4.46 MM  
Carat Weight  
Color Grade  
Clarity Grade  
Depth  
Table  
Girdle  
Culet  
Polish  
Symmetry  
Fluorescence  
Inscription(s)

2.09 CARATS  
E  
VS 1  
60.8%  
42.5%  
13.5%  
Slightly Thick To Thick (Faceted)  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG759525987

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